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STATE	EMENT BY	' APF	PLICANT	First Named Inv ntor	Nimmakayala et al.		
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Sheet	1	of	2	Attorney Docket Number	MII-94-69v18		

Fuenda		U.S. Patent Do	ocument	U.S. PATENT DOCUMEN	Date of Publication of	Pages, Columns, Lines.
Examiner Initials*	Cite No.1	Number	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
LBT	A1	4,724,222		Feldman	02-09-1988	
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Sheet	2	of	2	Attorney Docket Number	MII-94-69v18

OTHER PRIOR	R ART - I	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
LBT	A2	Feldman et al., "Wafer Chuck for Magnification correction in X-ray Lithography," Journal of Vacuum Science and Technology, Nov/Dec 1998, pp. 3476-3479, vol. B 16(6).	
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Filing Date	12/12/2003			
First Named Inventor	Nimmakayala et al.			
Group Art Unit	Unassigned			
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Attorney Docket Number	P122/MII-94-69V18			

				U.S. PATENT DOCUMEN	TS	
Examiner Initials*	Cite No.1	U.S. Patent Doc	kind Code ² (If known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
LBT	B1	4,326,805		Feldman et al.	04-27-1982	• • • • • • • • • • • • • • • • • • • •
	82	4,724,222		Felman	02-09-1988	
	B3	4,731,155		Napoli et al.	03-15-1988	
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	B5	5,072,126		Progler	12-10-1991	
	B6	5,204,739		Domenicali	04-20-1993	
	B7	5,206,983		Guckel et al.	05-04-1993	
	B8	5,425,848		Haisma et al.	06-20-1995	
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	B11	5,776,748		Singhvi et al.	07-07-1998	
	B12	5,802,914		Fassler et al.	09-08-1998	
	B13	5,877,036		Kawai	03-02-1999	
	B14	5,877,861		Ausschnitt et al.	03-02-1999	
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	B16	5,948,470	<u> </u>	Harrison et al.	09-07-1999	
	B17	6,039,897		Lochhead et al.	03-21-2000	
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V	B20	6,309,580	İ	Chou	10-30-2001	
LBT	B21	6,518,168		Clem et al.	02-11-2003	
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Application Number	10/735,110
Filing Date	12/12/2003
First Named Inventor	Nimmakayala et al.
Group Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	P122/MII-94-69V18

FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Office ³	Number*	Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴	
LBT	B22	DE	2800476		Lamprecht et al.	07-13-1978		L	
	B23	JP	1-196749		Matsumoto et al.	08-08-1989			
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Application Number						
Filing Date	12/12/2003					
First Named Inventor	Nimmakayala et al.					
Group Art Unit	Unassigned					
Examiner Name	Unassigned					
Attorney Docket Number	P122/MII-94-69V18					

OTHER PRIC	OR ART -	NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), tit item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue republisher, city and/or country where published.				
LBT	B27	CHOU et al., "Imprint of Sub-25 nm Vias and Trenches in Polymers," Applied Physics Letters, November 20, 1995, pp. 3114-3116, vol. 67(21).			
	B28	CHOU et al., "Imprint Lithography with 25-Nanometer Resolution," Science, Apr. 5, 1996, pp. 85-87, vol. 272.			
	B29	HAISMA et al., "Mold-Assisted Nanolithography: A Process for Reliable Pattern Replication," Journal of Vacuum Science and Technology, Nov/Dec 1996, pp. 4124-4128, vol. B 14(6).			
	B30	CHOU et al., "Imprint Lithography with Sub-10nm Feature Size and High Throughput," Microelectronic Engineering, 1997, pp. 237-240, vol. 35.			
	B31	FELDMAN et al., "Wafer chuck for magnification correction in x-ray lithography," American Vacuum Society, 1998, pp. 3476-3479.			
	B32	SCHEER et al., "Problems of the Nanoimprinting Technique for Nanometer Scale Pattern Definition," Journal of Vacuum Science and Technology, Nov/Dec 1998, pp. 3917-3921, vol. B 16(6).			
	B33	COLBURN. et al., "Step and Flash Imprint Lithography: A New Approach to High-Resolution Patterning", Proc. of SPIE, 1999, pp. 379-389, vol. 3676.			
	B34	CHOU et al., "Lithographically-induced Self Assembly of Periodic Polymer Micropillar Arrays," Journal of Vacuum Science and Technology, Nov/Dec 1999, pp. 3197-3202, vol. B 17(6).			
	B35	RUCHHOEFT et al., "Patterning Curved Surfaces: Template Generation by Ion Beam Proximity Lithography and Relief Transfer by Step and Flash Imprint Lithography," Journal of Vacuum Science and Technology, 1999, pp. 2965-2982, vol. 17.			
\downarrow	B36	CHOI et al., "Design of Orientation Stages for Step and Flash Imprint Lithography," Precision Engineering, Journal of the International Societies for Precision Engineering and Nanotechnology, 2001, pp. 192-199, vol. 25.			
LBT	B37	CHOU, "Nanoimprint Lithography and Lithographically Induced Self-Assembly," MRS Bulletin, July 2001, pp. 512-517.			

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	4	of	4	Attorney Docket Number	P122/MII-94-69V18	

OTHER PRIC	R ART - I	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
LBT	B38	CHOI et al., "High Precision Orientation Alignment and Gap Control Stages for Imprint Lithography	
	 	Processes," U.S. Patent Application 09/698,317, Filed with USPTO on October 27, 2000.	
LBT	B39	SREENIVASAN et al., "High-Resolution Overlay Alignment Methods and Systems for Imprint Lithography," U.S. Patent Application 09/907,512, Filed with USPTO on July 16, 2001.	
LBT	B40	CHOI et al., "Systems For Magnification And Distortion Correction For Imprint Lithography Processes," U.S.	
	D40	Patent Application 10/616,294, Filed with USPTO on July 9, 2003.	
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LBT	C1	5,669,303		Maracas et al.	09-23-1997		
LBT	C2	6,334,960		Willson et al.	01-01-2002		
LBT	C3	6,696.220		Bailey et al.	02-24-2004		
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				Group Art Unit	Unassigned		
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Sheet	3	3 of 4		Attorney Docket Number	P122/MII-94-69V18		

OTHER PRIC	OR ART -	NON PATENT LITERATURE DOCUMENTS							
Examiner Cite Initials* No.		publisher, city and/or country where published.							
LBT	C5	KRUG et al., "Fine Patterning of Thin Sol-Gel Films," Journal of Non-Crystalline Solids, 1992, pp. 447-450, vol. 147 & 148.							
	C6	Krauss et al., "Fabrication of Nanodevices Using Sub-25nm Imprint Lithography," Appl. Phys. Lett 67(21), 3114-3116, 1995							
	C7	CHOI et al., "Method and System of Automatic Fluid Dispensing for Imprint Lithography Processes," U.S. Patent Application Publication 2002/0094496. Published on July 18, 2002.							
	C8	CHOI et al., "Methods for High-Precision Gap and Orientation Sensing Between a Transparent Template and Substrate for Imprint Lithography," U.S. Patent Application Publication 2003/0093122. Published on July 18, 2002.							
	C9	VOISIN, "Methods of Manufacturing a Lithography Template," U.S. Patent Application 10/136,188, Filed with USPTO on May 1, 2002.							
	C10	SREENIVASAN et al., "Step and Repeat Imprint Lithography Systems," U.S. Patent Application 10/194,414. Filed with USPTO July 11, 2002.							
	C11	SREENIVASAN et al., "Step and Repeat Imprint Lithography Processes," U.S. Patent Application 10/194,991. Filed with USPTO July 11, 2002.	 						
	C12	OTTO M. et al., "Step and Repeat UV-Nanoimprint Lithography: Material Issues," Nanoimprint and Nanoprint Technology Conference, San Francisco, December 11-13, 2002.							
	C13	JOHNSON, et al., "Advances in Step and Flash Imprint Lithography, " SPIE Microlithography Conference, February 23-28, 2003.							
1	C14	CHOI et al., "A Chucking System and Method for Modulating Shapes of Subtrates," U.S. Patent Application 10/293,224. Filed with USPTO on November 13, 2002.							
LBT	C15	CHOI et al., "A Method For Modulating Shapes of Substrates," U.S. Patent Application 10/316,963. Filed with USPTO on December 11, 2002.							

Leo B. Tenconi/	Date Considered	01/20/2007
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				Application Number	10/735,110		
INF	ORMATION I	DIS	CLOSURE	Filing Date	12/12/2003		
STA	ATEMENT BY	/ AF	PPLICANT	First Named Inventor	Nimmakayala et al.		
				Group Art Unit	Unassigned		
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Sheet	4	of	4	Attorney Docket Number	P122/MII-94-69V18		

OTHER PRIO	R ART - I	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
LBT	C16	VOISIN, "Methods of Inspecting A Lithography Template," U.S. Patent Application 10/293,919. Filed with USPTO on November 13, 2002	
LBT	C17	CHOI et al., "A Conforming Template For Patterning Liquids Disposed On Substrates," U.S. Patent Application 10/614,716. Filed with USPTO on July 7, 2003.	
LBT	C18	SREENIVASAN et al., "Full-Wafer or Large Area Imprinting with Multiple Separated Sub-Fields for High Throughput Lithography," U.S. Patent Application 10/788,700. Filed with USPTO on February 27, 2004.	
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Examiner	/Leo B. Tentoni/	Date	
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¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.

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Substitut for form 1449A/PTO Complete if Known **Application Number** 10/735,110 INFORMATION DISCLOSURE **Filing Date** December 12, 2003 STATEMENT BY APPLICANT First Named inventor Pawan K. Nimmakayala **Group Art Unit** 2851 (use as many sheets as necessary) . Examiner Name Unassigned Sheet Attorney Docket Number P122-64V18

U.S. PATENT DOCUMENTS								
Examinar Initials*	Cito No.1	U.S. Palent Doc	Kind Code ² (# known)	Name of Palentee or Applicant of Cited Document	Date of Publication of Cited Document - MM-DD-YYYY	Pagna, Columna, Lines, Whore Helevers Passages or Heleven) Figures Appear		
LBT	D1	2003/0081193	A1	White et al.	05-01-2003			
LBT	D2	6,713,238	B1	. Chou et al.	03-30-2004			
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*	TEMENT I			FILING DATE	12/12/2003		
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				Group Art Unit	2851		
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Sheet	1	of	7	Attorney Docket Number	P122-64V58		

				F	OREIGN	PATENT DOCUM	ENTS				
Examin Initials*		Cite No. ¹	Foreign Patent Document Kind C Office Number* (if knot)		Code ⁵ Name of Patentee or Applicant of Cited Document		Date of Publication of Cited Document MM-DD-YYYY		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶	
L	ВТ	E1	5,414,514		Smith	n et al.	5/9/1995				
		E2	5,808,742		Evere	ett et al.	9/15/199	8			
		E3	6,088,103	 	Evere	ett et al.	7/11/200	0	· <u> </u>	· · · · · · · · · · · · · · · · · · ·	
		E4	6,137,562		Masu	ıyuki et al.	10/24/20	00			
		E5	6,391,217	B2	Scha	ffer et al.	5/21/200	2			
		E6	6,522,411	B1	Moor	et al.	2/18/200	3			
		E7	2004/0007799	A1	Choi	et al.	1/15/2004				
-		E8	2004/0021254	A1	Sree	nivasan et al.	2/5/2004				
		E9	2004/0021866	A1	Watts	s et al.	2/5/2004				
		E10	2004/0022888	A1	Sreer	nivasan et al.	2/5/2004				
		E11	2003/0092261	A1	Kond	o et al.	5/15/2003				
		E12	2003/0179354	A1	Araki	et al.	9/25/200	3			
		E13	2002/0177319	A1	Chou		11/28/20	02	·		
		E14	2002/0150398	A1	Choi	et al.	10/17/20	10/17/2002			
		E15	2004/0008334	A1	Sreer	nivasan et al.	1/15/200	4			
		E16	2004/0009673	A1	Sreer	nivasan et al.	1/15/200	4			
		E17	2004/0124566	A1	Sreer	nivasan et al.	7/1/2004				
LE	BT	E18	2004/0089979	A1	Rubir	1	5/13/200	4			

Examiner Signature	/Leo B. Tentoni/	Date Considered	01/20/2007
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	ORMATION ATEMENT I			FILING DATE	12/12/2003		
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				Group Art Unit	2851		
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Sheet	2	of	7	Attorney Docket Number	P122-64V58		

					FOREIGN	PATENT DOCUM	MENTS			_	
Examiner tnitials*	Cite No.1	Office 3	Foreign Pal		nent Kind Code ⁶ (if known)	Name of Patentee o Cited Docum		Cited	Publication of Document DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Τ°
LBT	E19	2004/00	86793	A1	Sreer	nivasan et al.	5/6/2004				
	E20	2004/00	53146	A1	Sreer	nivasan et al.	3/18/200	4			
	E21	3,783,5	20		King		1/8/1974				***

		E 19	2004/0000193	_^'	Sreenivasan et al.	5/0/2004	
		E20	2004/0053146	A1	Sreenivasan et al.	3/18/2004	
		E21	3,783,520		King	1/8/1974	
V		E22	6,150,231		Muller et al.	11/21/2000	
		E23	6,489,068	B1	Куе	12/3/2002	•
		E24	6,646,662	B1	Nebashi et al.	11/11/2003	
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		E27	4,600,309		Fay	7/15/1986	
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		E29	5,074,667		Miyatake	12/24/1991	
		E30	5,148,036		Matsugu et al.	9/15/1992	
		E31	5,148,037		Suda et al.	9/15/1992	
		E32	6,518,189	B1	Chou	2/11/2003	
		E33	2002/0132482	A1	Chou	9/19/2002	
		E34	2002/0167117	A1	Chou	11/14/2002	
		E35	6,482,742	B1	Chou	11/19/2002	
LB	T	E36	2003/0080471	A1	Chou	5/1/2003	

Examiner		Date	
Signature	/Leo B. Tentoni/	Considered	01/20/2007

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INIC	ORMATIO	N DISCI	OCUBE	APPLICATION NUMBER	10/735,110	
	ATEMENT			FILING DATE	12/12/2003	
317	ZI CHILIX I	DI AFF	LICAN	FIRST NAMED INVENTOR	Nimmakayala et al.	
				Group Art Unit	2851	
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Sheet	3	of	7	Attorney Docket Number	P122-64V58	

		,		FOREIGN	PATENT DOCL	IMENTS			
Examiner Cite No.1		Foreign Pa Office Numb		Name of Palentee or Applican (if known) Cited Document			Oate of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т
LBT	E37	2004/0036201	A1	Chou	et al.	2/26/200	4		
·	E38	2004/0192041	A1		g et al.	9/30/200	4		
	E39	6,828,244	B2	Chou		12/7/200	4		
	E40	6,809,356	B2	Chou		10/26/20	04		
	E41	5,737,064		Inoue	et al.	4/7/1998			
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- -	E43	2004/0197843	A1	Chou	et al.	10/7/200	4		
	E44	2004/0156108	A1	Chou	et al.	8/12/200	4		
	E45	2004/0137734	A1	Chou	et al.	7/15/200	4		
	E46	2004/0131718	A1	Chou	et al.	7/8/2004			
	E47	2004/0118809	A1	Chou	et al.	6/24/200	4		
	E48	2004/0046288	A1	Chou		3/11/200	4		
	E49	2003/0080472	A1	Chou		5/1/2003			
	E50	2003/0034329	A1	Chou		2/20/200	3		
	E51	2002/0042027	A1	Chou	et al.	4/11/200	2		
	E52	6,636,311	B1	Ina et	al.	10/21/20	03		
<u> </u>	E53	6,383,888	B1	Stirto	n	5/7/2002			
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LBT	E55	5,999,245	T	Suzu	ki	12/7/199	9	•	
	E56	2004/0223131	A1	Choi	et al.	11/11/20	04		
	E57	6,630,410	B2	Trapp	o et al.	10/7/200	3		_
	E58	6,580,172	B2	Mano	Mancini et al.		3		
	E59	10/999,898		Cherala et al.		11/30/20	04		
E60 E61		4,512,848			Deckman et al. Zhao		5		
		6,388,755					2		
	E62	6,295,120	B1	Miyat	Miyatake		1		
	E63	6,049,373		Miyatake		4/11/2000			
	E64	6,285,439	B1	Miyat	ake	9/4/2001			
	E65	6,791,669	B2	Poon		9/14/200	4		
	E66	6,517,995	B1	Jacol	penson et al.	2/11/200	3		
	E67	4,256,829		Danie	el	3/17/198	1		
	E68	2004/0110856	A1	Youn	g et al.	6/10/200	4		
	E69	5,028,366		Haral	kal et al.	7/2/1991		•	
	E70	5,601,641		Steph	nens	2/11/199	7		
V	E71	5,849,209		Kindt	-Larsen et al.	12/15/19	98		
LBT	E72	5,849,222		Jen e	t al.	12/15/19	98		

Examiner Signature /Leo B. Tentoni/	Date Considered	01/20/2007
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				Group Art Unit	2851		
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LB	Т	E73	wo	00/21689		Chou et al.	4/20/2000		
		E74	JP	02-92603		Kurikawa et al.	4/3/1990		
		E75	JP	02-24848		Kamio	1/26/1990		
		E76	wo	01/47003		Steiner et al.	6/28/2001		
		E77	wo	02/07199		Chou	1/24/2002		
		E78	wo	2004/114016		Chou et al.	12/29/2004		
		E79	wo	99/05724		Chou et al.	2/4/1999		
		E80	wo	03/010289		Chou et al.	2/6/2003		
	/	E81	wo	03/079416		Chou	9/25/2003		
LBT		E82	wo .	03/099536		Chou et al.	12/4/2003		
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Examiner Signature /Leo B. Tentoni/	Date 01/20/2007 Considered
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INFO	RMATION	DISCLO	SURE	APPLICATION NUMBER	10/735,110	
STAT	EMENT B	Y APPL	ICANT	FILING DATE	12/12/2003	
				FIRST NAMED INVENTOR	Nimmakayala et al.	
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Examiner	No.1 item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue nu		Т
nitials*	No.1	item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	'
LBT	E83	Colburn et al., Step and Flash Imprint Lithography for sub-100 nm Patterning, Proceedings of SPIE Vol. 3997, pp. 453 - 457, 1/1/2000	
	E84	Heidari, Nanoimprint Lithography at the 6 in. Wafer Scale, J. Vac. Sci. Technol. B 18(6), pp. 3557 - 3560, 11/1/2000	
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	E87	Translation of Japanese Patent 02-92603	
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	E89	Chou et al., Ultrafast and Direct Imprint of Nanostructures in Silicon, Nature, Col. 417, (June 2002), pp. 835-837, 6/1/2002	
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LBT	E91	Colburn et al., Development and Advantages of Step-and-Flash Lithography, Solid State Technology, 7/1/2001	T

Examiner Signature	/Leo B. Tentoni/	Date Considered	01/20/2007
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INFO	RMATION	DISCLO	SURE	APPLICATION NUMBER	10/735,110
STA	TEMENT B	Y APPL	ICANT	FILING DATE	12/12/2003
		•		FIRST NAMED INVENTOR	Nimmakayala et al.
(us	e as many sheets	as necessar	y)	Group Art Unit	2851
Sheet	7	of	7	Examiner Name	Unassigned
	1	<u> </u>	· · · · · · · · · · · · · · · · · ·	Attorney Docket Number	P122-64V58

OTHER PRIO	R ART -	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite, No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposlum, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
LBT	E92	Colburn et al., Characterization and Modeling of Volumetric and Mechanical Properties for Step and Flash Imprint Lithography Photopolymers, Journal of Vacuum Science Technology. Vol b. 19(6), 11/1/2001	
	E93	Bailey et al., Step and Flash Imprint Lithography: Defect Analysis, Journal of Vacuum Science, B 19(6), pp. 2806-2810, 11/1/2001	
	E94	Bailey et al., Step and Flash Imprint Lithography: Template Surface Treatment and Defect Analysis, Journal of Vacuum Science, B 18(6), pp. 3572-3577, 11/1/2000	
\downarrow	E95	Wronosky et al., Wafer and Reticle Positioning System for the Extreme Ultraviolet Lithography Engineering Test Stand, Emerging Lithography Technologies, Proceedings of SPIE Vol. 3997, pp. 829-839, 7/1/2000	
LBT	E96	Schneider et al., Stripes of Partially Fluorinated Alkyl Chains: Dipolar Langmuir Monolayers	

Examiner Signature	/Leo B. Tentoni/	Date Considered	01/20/2007
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Substitute f	or form 1449A	VPTO		Complete if Known		
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_		J. 72 (<u>2</u>		FILING DATE	12/12/2003	
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Sheet	7	of	12	Group Art Unit	1756	
JIRAL	*	L 61	<u></u>	Examiner Name	Christopher G. Young	
				Attorney Docket Number	P122-65V58	

				U.S. PATENT DOCUMEN	12	
iliolo*	Cite No. ¹	U.S. Patent Document Kind Code ² Number (<i>I known</i>)		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DC-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
LBT	F1 ⁻	6,665,119	T	Kurtz et al.	12/16/2003	
T	F2	6,019,166		Viswanath et al.	2/1/2000	
$\overline{\mathbf{V}}$	F3	5,563,684		Stagaman	10/8/1996	· · · · · · · · · · · · · · · · · · ·
LBT	F4	6,908,861		Sreenivasan et al.	6/21/2005	- · · · · · · · · · · · · · · · · · · ·
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	ORMATION ATEMENT B			APPLICATION NUMBER	10/735,110	
			//U11	FILING DATE	12/12/2003	
(use	as many sheets	es necessar	γ)	FIRST NAMED INVENTOR	Nimmakayala et al.	
				Group Art Unit	1756	
Sheet	2	of	2	Examiner Name	Christopher G. Young	
•				Attorney Docket Number	P122-65V58	

OTHER PRI	OR ART	NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T	
	-	·		
LBT	F5	PARK ET AL., Aligning Liquid Crystals Using Replicated Nanopattems, PSI Scientific Report 2002, Vol VII, p. 85 3/1/2003		
LBT	F6	APPLICATION NO. 11/142,834, naming Inventors Cherala et al., entitled Method of Varying Dimensions of a Substrate during Nano-Scale Manufacturing, filed 6/1/2005		
LBT	F7	APPLICATION NO. 11/142,839, naming Inventors Cherala et al., entitled Apparatusa to Vary Dimensions of a Substrate during Nano-Scale Manufacturing, filed 6/1/2005		
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